

F159-1997-0266-US4
JHA 1 /12
WANG ET AL.

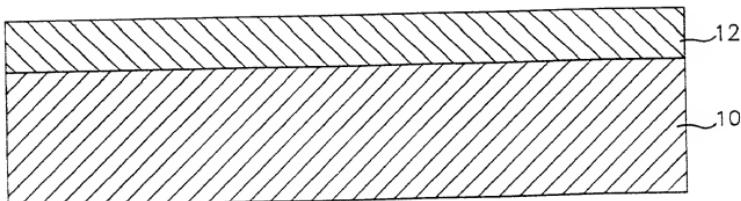


FIG. 1

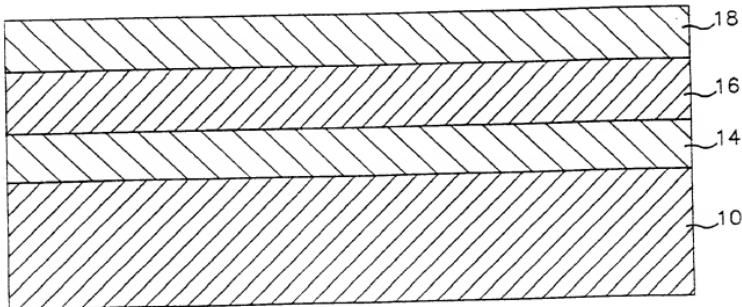


FIG. 2a

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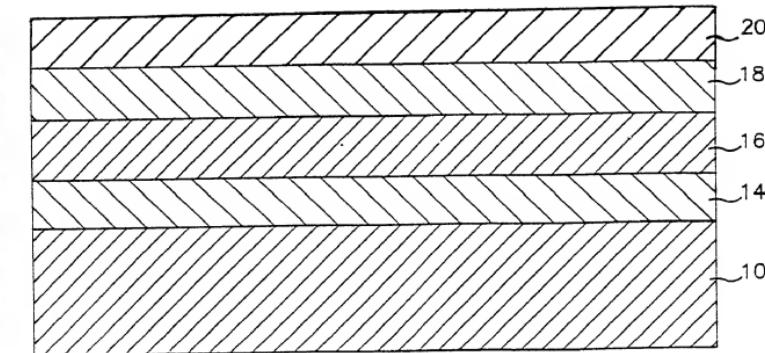


FIG. 2b

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TOSOSSO "SANTHESSO"

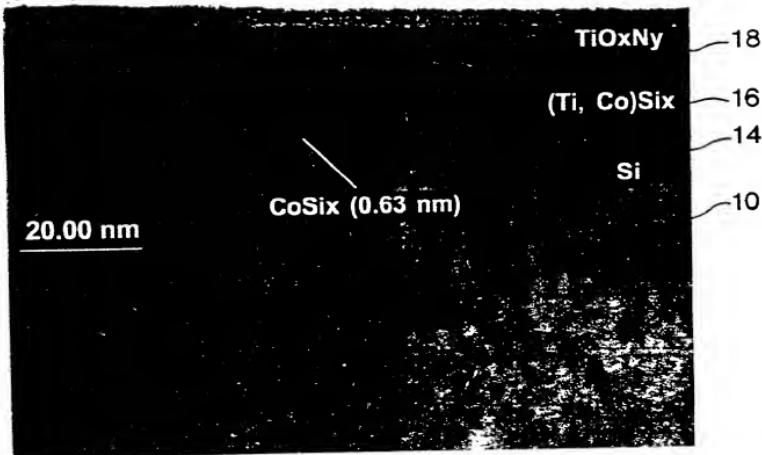


FIG. 3

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1000000 500000 100000 50000 10000

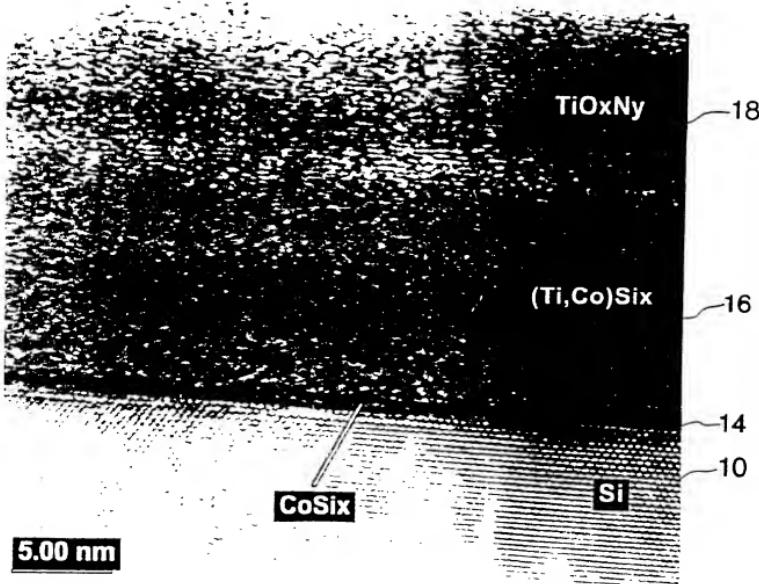


FIG. 4

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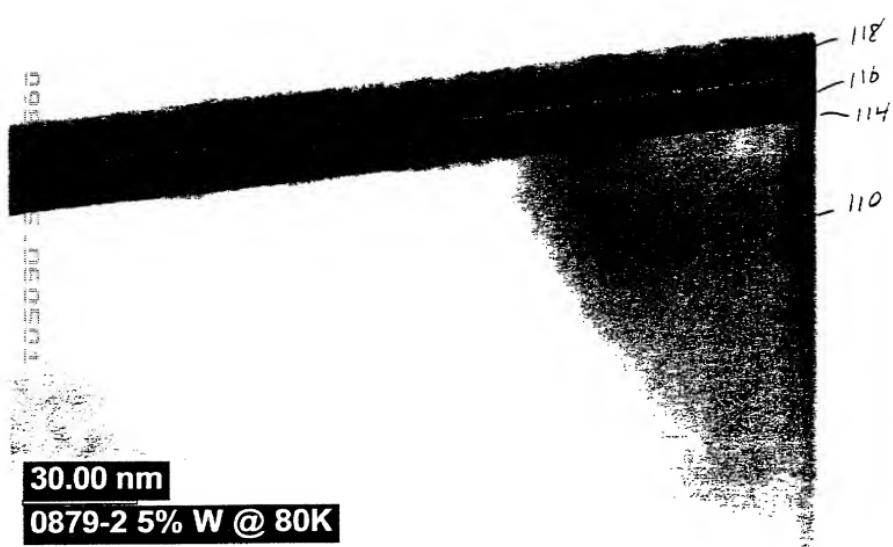


FIGURE 5

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FIGURE 6

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30.00 nm

0879-3 5% Mo of TiON/TiSi₂

8/9/99

FIGURE 7

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F159-1997-0266-U54

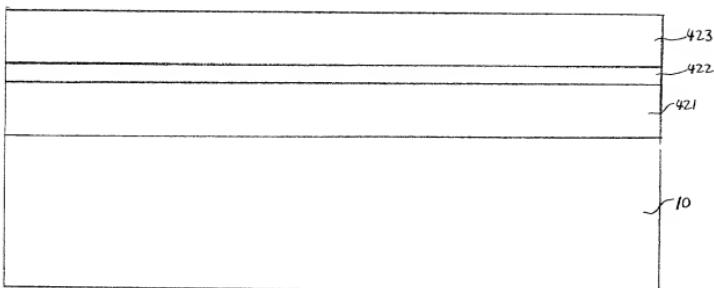


FIG. 8

FIS9-1997-0266-US4
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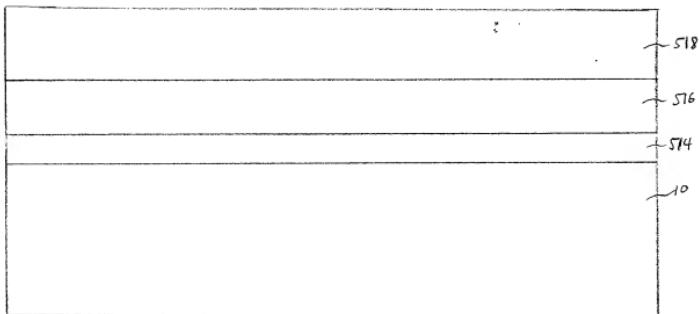


FIG. 9

FIS9-1997-0266-US4

JHA 10/12

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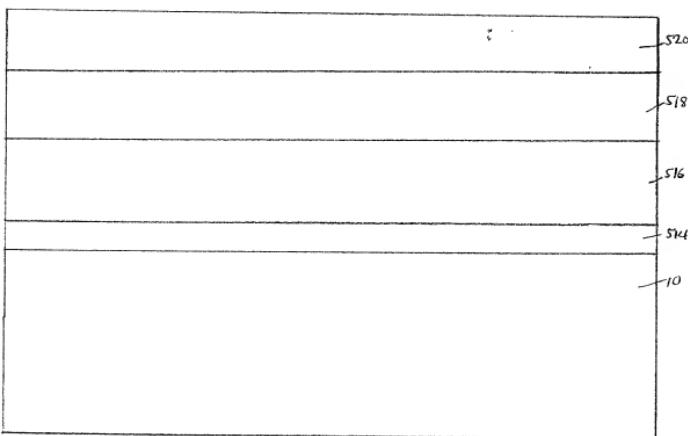


FIG. 10

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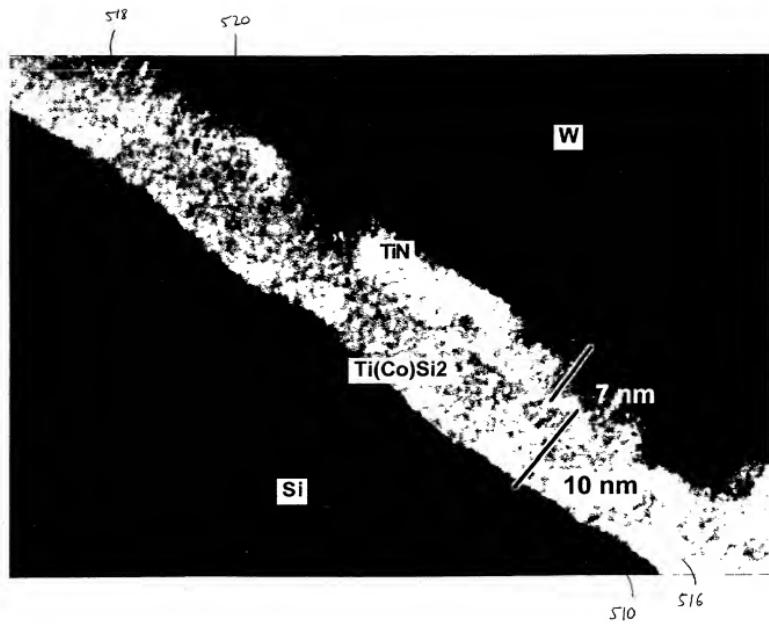


FIG. 11

F159-1997-0266-US4
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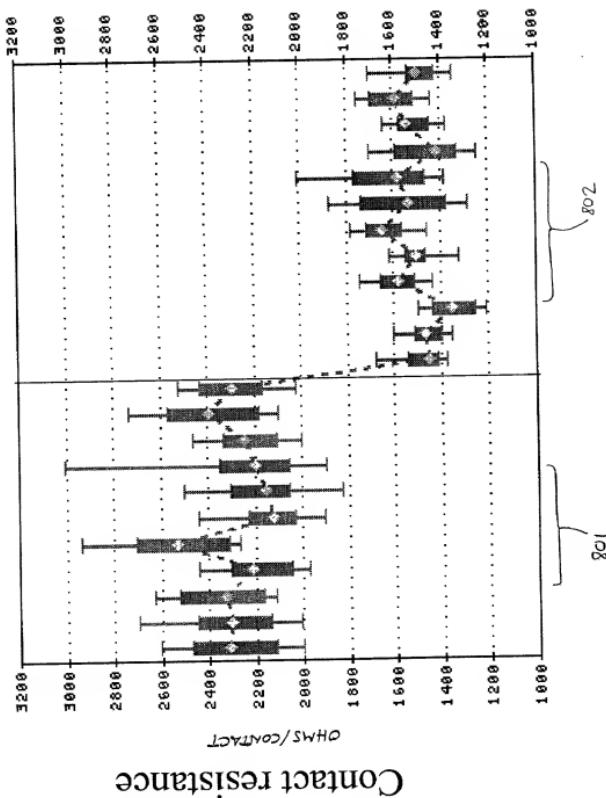


FIG. 12